

U.S. Department of Commerce, Patent and Trademark Office		Attorney Docket No.: 004-4911-1			
		Application No.: 09/940,242			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant(s): Michael L. Van De Vanter and Marat Boshernitsan			
(Use several sheets if necessary)		Filing Date: August 27, 2001			
		Group Art Unit: 2124 2124			
		Date Submitted: March 24, 2003			
U.S. Patent Documents					
*Examiner Initial	Document Number	Date	Name		
TF	AA 5,070,478	Dec. 3, 1991	Abbott		
	AB 5,079,700	Jan. 7, 1992	Kozoll et al.		
	AC 5,140,521	Aug. 18, 1992	Kozol et al.		
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	AF			Technology Center 2100	
	AG				
	AH				
	AI				
	AJ				
	AK				
Foreign Patent Documents			Translation		
	Document	Date	Country	Yes	No
AL					
AM					
AN					
AP					
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)					
AR					
AS					
AT					
Examiner	Date Considered	5/31/04			
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		Group Art Unit: 20A				
		Date Submitted: October 11, 2001				
U.S. Patent Documents						
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TF	AA 5,737,608	Apr. 7, 1998	Van De Vanter	395	701	
	AB 5,748,975	May 5, 1998	Van De Vanter	395	793	
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TF	AG 5,857,212	Jan. 5, 1999	Van De Vanter	707	519	
AH						
AI						
AJ						
AK						
Foreign Patent Documents						
						Translation
	Document	Date	Country	Class	Subclass	Yes
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AM						
AN						
AP						
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
TF	AR	Rolf Bahlke and Gregor Snelting, "The PSG System: From Formal Language Definitions to Interactive Programming Environments," <i>ACM Transactions on Programming Languages and Systems</i> Vol. 8, No. 4 (Oct. 1986), pp. 547-576.				
TF	AS	R. A. Balance, S. L. Graham and M. L. Van De Vanter, "The Pan Language-Based Editing System," <i>ACM Transactions on Software Engineering and Methodology</i> , Vol. 1, No. 1 (Jan. 1992), pp. 95-127.				
TF	AT.	P. Borras et al., "CENTAUR: the system," <i>Proceedings ACM SIGSOFT '88: Third Symposium on Software Development Environment</i> (Nov. 1988), pp. 14-24.				
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant(s): Van De Vanter
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NON PATENT LITERATURE DOCUMENTS		
*Examiner Initial	CRM TRADEMARK OFFICE OCT 09 2001 SCA2	(Including name of author in capital letters, title of article, title of item, date, pertinent pages, volume-issue number(s), publisher, city and/or country where published.)
	AA	V. Donzeau-Gouge et al., "Programming Environments Based on Structured Editors: The MENTOR Experience," <i>Interactive Programming Environments</i> , David R. Barstow et al., editors, McGraw-Hill, New York, NY (1984), pp. 128-140.
	AB	Bernard Lang, "On the Usefulness of Syntax Directed Editors," <i>Advanced Programming Environments, Lecture Notes in Computer Science</i> , vol. 244, Reidar Conradi et al, editors, Springer Verlag, Berlin (1986), pp. 47-51.
	AC	S. Letovsky and E. Soloway, "Delocalized Plans and Program Comprehension," <i>IEEE Software EE</i> (May 1986), pp. 41-49.
	AD	Lisa Rubin Neal, "Cognition-Sensitive Design and User Modeling for Syntax-Directed Editors," <i>Proceedings SIG-CHI Conference on Human Factors in Computing Systems</i> , Toronto, Canada (April 1987), pp. 99-102.
	AE	David Notkin, "The GANDALF Project," <i>Journal of Systems and Software</i> Vol. 5, No. 2 (May 1985), pp. 91-105.
	AF	T. Reps and T. Teitelbaum, <i>The Synthesizer Generator Reference Manual, Texts and Monographs in Computer Science</i> , 3rd Ed., Springer-Verlag, NY, 1989, 180 pages.
	AG	E. Soloway and K. Ehrlich, "Empirical Studies of Programming Knowledge," <i>IEEE Transactions on Software Engineering</i> , Vol. SE-10, No. 5 (Sept. 1984), pp. 595-609.
	AH	Richard M. Stallman, "EMACS: The Extensible, Customizable, Self-Documenting Display Editor," <i>Proceedings of the ACM-SIGPLAN SIGOA Symposium on Text Manipulation, SIGPLAN Notices</i> , Vol. 16, No. 6 (June 8-10, 1981), pp. 147-156.
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	AJ	M. Van De Vanter et al., "Coherent User Interfaces for Language-Based Editing Systems," <i>International Journal of Man-Machine Studies</i> , Vol. 37, No. 4 (1992), pp. 431-466.
	AK	Michael L. Van De Vanter, "Practical Language-Based Editing for Software Engineers," <i>Software Engineering and Human-Computer Interaction: ICSE '94 Workshop on SE-HCI: Joint Research Issues, Sorrento, Italy, May 1994 Proceedings, Lecture Notes in Computer Science</i> , Vol. 896, Richard N. Taylor and Joelle Coutaz, editors, Springer Verlag, Berlin (1995), pp. 251-267.
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